

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/656,353	HEGER ET AL.	
Examiner	Art Unit	

1765

Kin-Chan Chen

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED					
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
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EAST key words search, USPAT, USPGPUB, EPO,JPO,Derwent, IBM-TDB, inventor search.	5/24/2005	Ku			
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